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Complete if Known

Application Number	10/646,013
Filing Date	8/22/2003
First Named Inventor	Cheng H. Huang
Art Unit	2826
Examiner Name	Remmon R. Forde
Attorney Docket Number	A1063

(Use as many sheets as necessary)

Sheet 1 of 2

Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		US- 4,433,331	02-21-1984	Kollaritsch	
		US- 4,609,986	02-21-1986	Hartmann et al.	
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A. J.		US- 10,780,427	N/A	Chih-Ching Shih et al.	

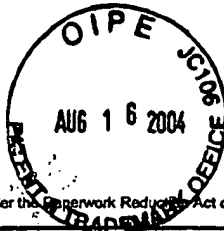
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete If Known			
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Sheet	2	of	2	Attorney Docket Number	A1063

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
A. S.		WEI ZHANG ET AL., "Energy Effect of the Laser-Induced Vertical Metallic Link", IEEE Transactions on Semiconductor Manufacturing, Vol 14, No. 2, May 2001 pp 163-169	
		"Analyzing the process window for laser copper-link processing" Solid State Technology - Semiconductor manufacturing and wafer fabrication, Jan 8, 2003	
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		MOHSEN ALAVI "A PROM Element Based on Salicide Agglomeration of Poly Fuses in a CMOS logic process" IEEE International Electron Devices Meeting, December 1997	
		NORIAKI SATO et al. "A New Programmable Cell Utilizing Insulator Breakdown", IEDM 1985, pp 639-642	
		JINBONG KIM et al. "Three-Transistor One-Time Programmable (OTP) ROM Cell Array Using Standard CMOS Gate Oxide Antifuse", IEEE Electron Device Letters, Vol 24, No. 9, September 2003 pp. 589-591	
A. S.		WEI ZHANG et al. "Laser-Formed Vertical Metallic Link and Potential Implementation in Digital Logic Integration", PROC MAPLD, MD, 1999 pp 1-7 (B5)	

Examiner Signature		Date Considered	11/12/04
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